

**CERTIFICATE OF TRANSMISSION**

I hereby certify that this correspondence (along with any paper referred to as being attached or enclosed) is being submitted *via* the USPTO EFS Filing System; Mail Stop RCE; Commissioner for Patents; P.O. Box 1450; Alexandria, VA 22313-1450.

Date: May 31, 2006 /Christina M. Padamonsky/  
Christina M. Padamonsky

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re patent application of:

Applicant(s): Cyrus E. Tabery *et al.*

Examiner: Ram N. Kackar

Serial No: 09/955,517

Art Unit: 1763

Filing Date: September 18, 2001

Title: *IN-SITU OR EX-SITU PROFILE MONITORING OF PHASE OPENINGS ON ALTERNATING PHASE SHIFTING MASKS BY SCATTEROMETRY*

**Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450**

---

---

**REPLY TO FINAL OFFICE ACTION DATED MAY 4, 2006**

---

---

Dear Sir:

Favorable reconsideration of the above-identified patent application is respectfully requested in view of the following comments.